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NGC-212/12-1167

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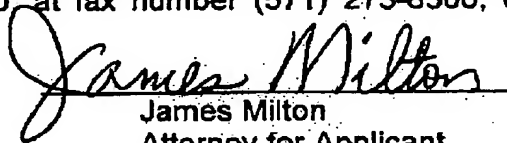
Patent Application

Inventor(s): Raffi Nazare Elmadjian
Case No.: NGC-212/12-1167
Serial No.: 10/688,238
Filing Date: 10/18/2003
Title: WAFER ETCHING TECHNIQUES

Examiner Ken Chan Chin
Art Unit: 1765

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being sent via facsimile transmission to Commissioner for Patents, Mail Stop RCE, Group Art Unit 1765, Attention: Examiner Ken Chan Chin, P.O. Box 1450, Alexandria, VA 22313-1450 at fax number (571) 273-8300, on February 20, 2006.



James Milton
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Date of Signature: February 20, 2006

Commissioner for Patents
Mail Stop RCE
Group Art Unit 1765
Attention: Examiner Ken Chan Chin
P.O. Box 1450
Alexandria, VA 22313-1450
Fax Number (571) 273-8300

PRELIMINARY AMENDMENT

Dear Sir:

This paper is filed in response to the Final Office Action mailed November 10, 2005 and the Advisory Action mailed on February 14, 2005 in connection with the above-designated application. The six-month period for responding to the final Office Action expires on May 10, 2005. Therefore, this Response is timely filed within the six-month period.